

<b>Notice of References Cited</b>	Application/Control No. 10/755,719	Applicant(s)/Patent Under Reexamination HAVENER, JOHN P.	
	Examiner Zoila E. Cabrera	Art Unit 2125	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-4,815,014	03-1989	Lipner et al.	702/184
	B	US-6,102,958	08-2000	Meystel et al.	703/2
	C	US-			
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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**NON-PATENT DOCUMENTS**

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